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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10040233	FILING DATE 11/07/2001	CLASS 257	SUBCLASS 141	GAU 2811	EXAMINER L. J. F. [Signature]
**APPLICANTS: Chiou Yu-Zung; Lin:Kuen-Hsien; Lieh Chen; Hsu Shou-Yi;					
**CONTINUING DATA VERIFIED: [Signature]					
** FOREIGN APPLICATIONS VERIFIED: [Signature]					
PG-PUB		DO NOT PUBLISH <input checked="" type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed		<input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO	
35 USC 119 conditions met		<input type="checkbox"/> yes <input checked="" type="checkbox"/> no		TS01-102	
Verified and Acknowledged Examiners's initials		[Signature]			
TITLE : Novel design and fabrication method for finger n-type doped photodiodes with high sensitivity for CIS products					
U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	
		Print Claim for O.G.	
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
		Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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